FORM F U.S. DEF

FORM PTO-1449 (SUBSTITUTE)

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b)) Attorney Docket No.: L&L-10078

Applic. No.

Alfred Kersch et al.

09/939,330CEIV

Applicant

JAN 05 2004

Filing Date

Group Art Unit

August 24, 2001

1762

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
EF	Α	5,104,690	04/14/92	Greenwald			
EF	В	5,753,300	05/19/98	Wessels et al.			
	С						
	D						
	E	,			,		
	F						
	G						
	н						
	ı						

FOREIGN PATENT DOCUMENT

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRAI YES	
J	60 026 663	02/09/85	Japan			X	
 К							
L							
М							
N							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

EF	L.A. Wills et al.: "Deposition of Ferroelectric Bi ₄ Ti ₃ O ₁₂ Thin Films", Extended Abstracts, Fall Meeting, Seattle, Washington, 90/2, 1990, p. 701, Princeton, NJ, XP-000294124

EXAMINER

DATE CONSIDERED

5/17/04

EXAMINER. Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

E	U.S. DEPART PATENT AND	PTO-1449 (SUBSTITUTE) PARTMENT OF COMMERCE AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (37 CFR 1.98(b))			Attorney Docket No.: Applic. No. L&L-I0078 09/939,330 Applicant Alfred Kersch et al. Filing Date Group Art Unit August 24, 2001 1762				
	RADEMIN	U.S. PATENT DOCUMENTS							
	EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB	FILING	
Ì	FF	Α	6,191,054 B1	02/20/01	Ohtsuka et al.	CLASS	CLASS	DATE	
Ì		В				_			
		С							
		D							
		Ε							
		F							
		G							
		Н							
L		1			·				
	FOREIGN PATENT DOCUMENT								
	13.1	J	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO	
ŀ		К							
┝		L							
ŀ	·	М							
r		N							
	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)								
		0							
		Р				,			
EXAMINER DATE CONSIDERED 5/17/04									
L	EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								